Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	polymer near3 movable adj elctrode and mems	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/27 15:04
L2	0	polymer same movable adj elctrode and mems	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/27 15:04
L3	7028	movable adj electrode	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/27 15:05
L4	301	movable adj electrode and polymer	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/27 15:06
L5	40	movable adj electrode and polymer same support	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/27 15:06
L6	10	movable adj electrode and polymer same support and mems	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/27 15:06
S1	1	("20050078348").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/27 15:03
S2	1	("5835255").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/26 14:32
S3	673297	cavity cavities	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/26 10:49
S4	132749	electrode and second near2 electrode	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/26 10:50
S5	352272	spacer supporter standoff	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/26 10:50
S6	1969	S3 and S4 and S5	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/26 10:55

S7	650	S6 and display	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/26 12:08
S8	1729	cmos same mems	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/26 12:09
S9	776	S3 and S8	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/26 12:10
S10	177664	sidewall	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/26 12:10
S11	181	S9 and S10	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/26 12:17
S12	402592	ito indium adj tin adj oxide	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/26 12:12
S13	303	cmos bond$3 mems	US-PGPUB; USPAT; USOCR; EPO; JPO	SAME	OFF	2006/01/26 12:55
S22	46	cmos and mems and movable adj electrode	US-PGPUB; USPAT; USOCR; EPO; JPO	SAME	OFF	2006/01/26 12:59
S23	11118	sidewall same spacer	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/26 12:59
S24	902	S23 and S3	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/26 13:03
S26	7028	movable adj electrode	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/27 15:05
S27	2	S24 and S26	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/26 13:02

S28	43	("2534846" | "3439973" | "3443854" | "3653741" | "3813265" | "3955880" | "4099854" | "4228437" | "4377324" | "4389096" | "4403248" | "4445050" | "4519676" | "4531126" | "4663083" | "4681403" | "4748366" | "4790635" | "4982184" | "5022745" | "5044736" | "5075796" | "5124834" | "5153771" | "5168406" | "5231532" | "5233459" | "5311360" | "5381253" | "5401983" | "5459610" | "5497172" | "5500635" | "5500761" | "5579149" | "5619059" | "5636052" | "5703710" | "5710656").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 13:17
S29	14	("5710656").URPN.	USPAT	OR	OFF	2006/01/26 13:22
S30	103	("2534846" | "3439973" | "3443854" | "3653741" | "3656836" | "3813265" | "3955880" | "4099854" | "4228437" | "4377324" | "4389096" | "4403248" | "4445050" | "4519676" | "4531126" | "4663083" | "4681403" | "4748366" | "4786128" | "4790635" | "4982184" | "5022745" | "5044736" | "5078479" | "5124834" | "5153771" | "5168406" | "5231532" | "5233459" | "5311360" | "5401983" | "5459610" | "5497172" | "5500635" | "5500761" | "5579149" | "5619059" | "5636052" | "5710656" | "5739945" | "5784190" | "5825528" | "5835255").PN. OR ("5986796"). URPN.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 13:24
S31	1	S30 and sidewall	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 13:25
S32	16	moveable adj electrode and stack	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 13:28
S33	14	"6097092"	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 13:33
S34	28	freestanding near3 (stack gate)	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 13:35
S35	5	lcd and S23 and stack	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 13:36

S36	9	freestanding near3 gate	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 13:37
S37	12	interference near1 display near1 cell	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2006/01/26 14:32
S38	2	("5835255" | "6448709").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 15:15
S39	31623	micro electro mechanical system or mems	US-PGPUB; USPAT; USOCR	ADJ	OFF	2006/01/26 15:16
S40	0	S39 same (gate stack cmos mosfet) and sidwall same spacer	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 15:17
S41	0	S39 same sidwall same spacer	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 15:17
S42	7	S39 same sidewall same spacer	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 15:23
S43	4	release adj layer and S39 and sidewall same spacer	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 15:26
S44	1464	spacer near5 sidewall near5 electrode	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 15:27
S45	3	S39 and S44	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 17:02
S46	0	polysilicon near2 support same S26	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 17:29
S47	111	polysilicon same S26	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 17:02
S48	1	paraffin same S26	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 17:31
S49	217	macromolecule polymer	US-PGPUB; USPAT; USOCR	ADJ	OFF	2006/01/26 17:31
S50	1	S49 and S26	US-PGPUB; USPAT; USOCR	ADJ	OFF	2006/01/26 17:31
S51	21	paraffin and S26	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/26 17:31